### PATENT ASSIGNMENT

# Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE: NEW ASSIGNMENT

NATURE OF CONVEYANCE: ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
Jung-Hee PARK	09/16/2010

### **RECEIVING PARTY DATA**

Name:	Hynix Semiconductor Inc.
Street Address:	San 136-1, Ami-ri, Bubal-eup, Icheon-si
City:	Gyeonggi-do
State/Country:	REPUBLIC OF KOREA
Postal Code:	467-701

### PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	12894840	

### CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER: P08HC054/US

NAME OF SUBMITTER: Jung H. Kim

**Total Attachments: 1** 

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PATENT REEL: 025072 FRAME: 0264

## ASSIGNMENT OF PATENT APPLICATION

WHEREAS I/We, the below named inventor(s) has made an invention entitled: METHOD FOR FARRICATING SEMICONDUCTOR DEVICE

METHOD FOR FABRIC	LATING BENICONDUCTOR I	DE VICE	
For which I/We filed an application	cation for Letters Patent of the United Sta on for Letters Patent of the United States of the	tes concurrently herewith; and/or n September 30, 2010 (Application No.	
assignor(s), have sold, assigned, tr Hynix Semiconductor Inc., a cor ri, Bubal-eup, Ichcon-si, Gyeong lawful successors and assigns my/ and improvement(s) set forth there of and substitutes for said applicat	I valuable consideration, the receipt of when ansferred, and set over, and do hereby sel reporation of the Republic of Korea, whose gi-do 467-701, Republic of Korea (hereifour entire right, title, and interest in and to ein; and any and all continuations, continuation for said Letters Patent and any and all may be granted thereon or therefore; and nt.	l, assign, transfer, and set over unto e post office address is San 136-1, Ami- inafter referred to as Assignee), its o this application and the invention(s) ations-in-part, divisionals, and renewals Letters Patent of the United States and	
foreign to the United States directl	ignee, its lawful successors and assigns to ly in its own name, and to claim priority o Patent of the United States and of countr ations and treaties.	f the filing date of any of the above-	
of any country or countries foreign	uest the Commissioner of Patents and Tra n to the United States, whose duty it is to invention to the Assignee, its successors at	ssue patents on applications as foresaid,	
	nat I/We have the full right to convey the i ot execute any agreement in conflict with		
AND, I/WE HEREBY further covenant and agree that I/We will, without further consideration, communicate with said Assignee, its successors and assigns, any facts known to me/us respecting this invention and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver any and all papers that may be necessary or desirable to perfect the title to this invention in said Assignee, its successors and assigns, execute all divisional, continuation, and reissue applications, make all rightful oaths and generally do everything possible to aid said Assignee, its successors and assigns, to obtain and enforce proper patent protection for this invention in the United States and in countries foreign thereto, it being understood that any expense incident to the execution of such papers shall be borne by the Assignee, its successors and assigns.			
AND, I/WE HEREBY authorize and request the attorneys of record to insert the serial number and filing date of said application now identified by the attorney docket number and title set forth above as soon as the same shall have been known to them by the United States Patent and Trademark Office.			
IN TESTIMONY WHEREOF, I/W	/e have hereunto set our hands.		
Signature of first assignor: Name of first assignor: Address:	PARK, Jung-Hee PARK, Jung-Hee San 136-1, Ami-ri, Bubal-eup, Ichcon-si, G	Date Saptember 16,2010  Syconggi-do 467-701, Republic of Korea	
Signature of second assignor: Name of second assignor: Address:		Date	

**PATENT REEL: 025072 FRAME: 0265** 

**RECORDED: 09/30/2010**